

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : James S. Im
Serial No. : To be assigned (National Phase of PCT/US03/025947)
Filed : Herewith
For : A SINGLE-SHOT SEMICONDUCTOR PROCESSING SYSTEM AND
METHOD HAVING VARIOUS IRRADIATION PATTERNS
Customer No.: 21003

PRELIMINARY AMENDMENT**EXPRESS MAIL NO.: ED 291 600 791 US**

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the present application, please consider the following amendments.

Amendments to the Specification begin at page 2 of this paper.